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QUERY CONTROL FORM		RTIS USE ONLY
Application No. 10/053, 576 Prepared by	MB.	Tracking Number 05899150
Examiner-GAU DONGHOLTV - 7834 Date	3/10/04	Week Date 2/2/04
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a. Serial No.	f. Foreign Priority	k. Print Claim(s)	p. PTO-1449		
b. Applicant(s)	g. Disclaimer	I. Print Fig.	q. PTOL-85b		
c. Continuing Data	h. Microfiche Appendix	m. Searched Column	r. Abstract		
d. PCT	i. Title	n. PTO-270/328	s. Sheets/Figs		
e. Domestic Priority	j. Claims Allowed	o. PTO-892	t. Other		

SPECIFICATION	MESSAGE
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b. Text Continuity	Through citations. (copy provided for reference).
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e. Illegible Text	FIG. 58 (b) - no Ft6. 58(9).
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XAMINER INITIAL	DOCUMENT NUMBER					FILING	DATE
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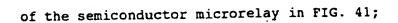


FIG. 50 is a relation drawing used to describe the function of the semiconductor microrelay in FIG. 41;

FIG. 51 is a relation drawing used to describe the function of the semiconductor microrelay in FIG. 41;

FIG. 52 is a partially cutaway view in perspective of the structure of another semiconductor microrelay;

FIG. 53 is a top view to show the structure of a semiconductor microactuator in a related art;

10 FIG. 54 is a sectional view to show the structure of the semiconductor microactuator in the related art;

FIG. 55 is a sectional view to show the structure of a semiconductor microrelay in a related art; and

FIG. 56 is a schematic drawing used to describe the function of the semiconductor microrelay in the related art.

FIG. 57 is a partially cutaway view in perspective of the structure of a semiconductor microactuator using a semiconductor device corresponding to another embodiment of the invention;

FIG. 58 (b) is a sectional view to show the structure of the semiconductor microactuator in FIG. 57;

FIG. 58(b) is a top view to show the structure of the semiconductor microactuator in FIG. 57;

FIG. 59 is a partially cutaway view in perspective of the structure of a semiconductor microactuator using a semiconductor device corresponding to another embodiment of the invention;